

Electrooptic Matched Filter Controlled by Independent Voltages Applied to Multiple Sets of Electrodes

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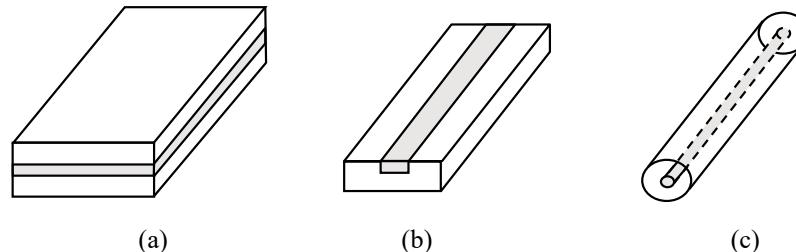
I. Introduction

- › Optical filters - essential components in a wavelength-division multiplexed (WDM) optical networks
- › Electrooptic tunable filters (EOTFs) - a good solution for sub-microsecond tunability through TE-TM mode coupling
- › Conventional EOTF - a Mach-Zehnder interferometer structure, phase-matched polarization conversion, and polarization beam splitter
- › Electrooptic matched filter (EMF) is a new type of EOTF providing wide spectral tuning range and rapid tuning
- › EMF - designed for operation in the 1550 nm wavelength regime for 100 GHz (0.8 nm) channel spacing corresponding to the ITU-T grid

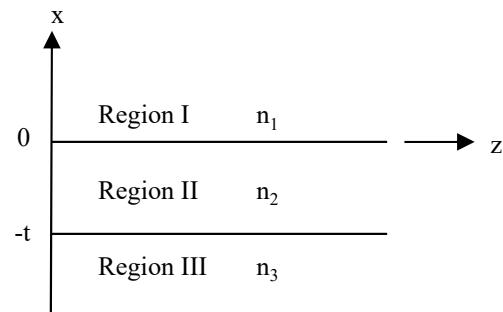
II. Mode Coupling in Optical Waveguide

A. TE and TM Modes in Slab Dielectric Waveguide

- › Optical waveguide



- › The step-index planar waveguide is the simplest structure for discussing fundamental properties of guided modes



Wave Equation in Slab Waveguide

- › The allowed modes of this waveguide are obtained from the wave equation given by

$$\nabla^2 \mathbf{E}(\mathbf{r}) + k_0^2 n^2(\mathbf{r}) \mathbf{E}(\mathbf{r}) = 0$$

- › The solutions are subject to the boundary conditions: tangential components of \mathbf{E} and \mathbf{H} are continuous at the interfaces $x = 0$ and $-t$
- › Assuming an isotropic and lossless medium in the waveguide, Maxwell's equations written by

$$\nabla \times \mathbf{H} = -\varepsilon_0 n^2 \frac{\partial \mathbf{E}}{\partial t} \quad \text{and} \quad \nabla \times \mathbf{E} = -\mu_0 \frac{\partial \mathbf{H}}{\partial t}$$

yields two orthogonal modes

TE and TM Modes

	■ Transverse electric (TE) mode	■ Transverse magnetic (TM) mode
Wave equation	$\frac{\partial^2}{\partial x^2} E_y + (k_0^2 n^2 - \beta^2) E_y = 0$	$\frac{\partial^2}{\partial x^2} H_y + (k_0^2 n^2 - \beta^2) H_y = 0$
Maxwell's equations	$H_y = -\frac{\beta}{\omega \mu_0} E_y$ $H_z = -\frac{1}{j \omega \mu_0} \frac{\partial E_y}{\partial x}$	$E_x = \frac{\beta}{\omega \epsilon_0 n^2} H_y$ $E_z = \frac{1}{j \omega \epsilon_0 n^2} \frac{\partial H_y}{\partial x}$
TE/TM Mode field solution in each layer	$E_y = C e^{-qx}, x > 0$ $E_y = C [\cos(hx) - \frac{q}{h} \sin(hx)], -t \leq x \leq 0$ $E_y = C [\cos(ht) + \frac{q}{h} \sin(ht)] e^{p(x+t)}, x < -t$	$H_y = -C' \frac{h}{q} e^{-qx}, x > 0$ $H_y = C' [-\frac{h}{q} \cos(hx) + \sin(hx)], -t \leq x \leq 0$ $H_y = -C' [\frac{h}{q} \cos(ht) + \sin(ht)] e^{p(x+t)}, x < -t$
Eigenvalue equation	$\tan(ht) = \frac{p + q}{h - \frac{pq}{h}}$	$\tan(ht) = \frac{\frac{n_2^2}{n_3^2} p + \frac{n_2^2}{n_1^2} q}{h - \left(\frac{n_2^2}{n_1 n_3}\right)^2 \frac{pq}{h}}$

where $q = \sqrt{\beta^2 - k_0^2 n_1^2}$, $h = \sqrt{k_0^2 n_2^2 - \beta^2}$, $p = \sqrt{\beta^2 - k_0^2 n_3^2}$ and $k_0 n_3 < \beta < k_0 n_2$

II. Mode Coupling in Optical Waveguide

B. TE/TM Polarization Converter

- › Coupled Mode Theory in Optical Waveguide

In an isotropic charge-free medium, eigen modes satisfy the wave equation in the form

$$\nabla^2 \mathbf{E}(\mathbf{r}, t) = \mu\epsilon(\mathbf{r}) \frac{\partial^2 \mathbf{E}(\mathbf{r}, t)}{\partial t^2}$$

using

$$\nabla \cdot (\epsilon \mathbf{E}) = 0$$

$$\nabla \times \nabla \times \mathbf{E} \equiv \nabla(\nabla \cdot \mathbf{E}) - \nabla^2 \mathbf{E}$$

$$\nabla \times \mathbf{H} = -\epsilon_0 n^2 \frac{\partial \mathbf{E}}{\partial t}$$

Curl and substitute

$$\nabla \times \mathbf{E} = -\mu_0 \frac{\partial \mathbf{H}}{\partial t}$$

Coupled Mode Theory Continued...

- With the electric polarization of the medium $\mathbf{P}(\mathbf{r}, t)$

$$\nabla^2 \mathbf{E}(\mathbf{r}, t) = \mu \epsilon_0 \frac{\partial^2 \mathbf{E}(\mathbf{r}, t)}{\partial t^2} + \mu \frac{\partial^2}{\partial t^2} \mathbf{P}(\mathbf{r}, t)$$

where $\mathbf{P}(\mathbf{r}, t) = [\epsilon(\mathbf{r}) - \epsilon_0] \mathbf{E}(\mathbf{r}, t)$, $\epsilon(\mathbf{r})$: Medium dielectric constant

- If the deformation in the waveguide is taken into account, the induced perturbation in the polarization results in

$$\nabla^2 \mathbf{E}(\mathbf{r}, t) = \mu \frac{\partial^2}{\partial t^2} [\epsilon(\mathbf{r}) \mathbf{E}(\mathbf{r}, t) + \mathbf{P}_{pert}(\mathbf{r}, t)]$$

- Assuming only the TE mode

$$\nabla^2 E_y(\mathbf{r}, t) - \mu \frac{\partial^2}{\partial t^2} \epsilon(\mathbf{r}) E_y(\mathbf{r}, t) = \mu \frac{\partial^2}{\partial t^2} [P_{pert}(\mathbf{r}, t)]_y$$

- The following equation is derived after some calculation and used to consider TE and TM mode interaction.

$$\frac{dA_s^-}{dz} e^{j(\omega t + \beta_s z)} - \frac{dA_s^+}{dz} e^{j(\omega t - \beta_s z)} - c.c. = -\frac{j}{2\omega} \frac{\partial^2}{\partial t^2} \int_{-\infty}^{\infty} [P_{pert}(\mathbf{r}, t)]_y E_y^s(x) dx$$

Electrooptic Effect in a Uniaxial Crystal

- › An electrooptic material undergoes the change in the refractive index induced by applied electric field linearly (Pockels effect) or quadratically (Kerr effect) and this phenomenon is called the electrooptic effect
- › The electric flux density **D** in an anisotropic dielectric media is written by with dielectric constants and electric fields

$$\begin{aligned}D_x &= \varepsilon_{11}E_x + \varepsilon_{12}E_y + \varepsilon_{13}E_z \\D_y &= \varepsilon_{21}E_x + \varepsilon_{22}E_y + \varepsilon_{23}E_z \\D_z &= \varepsilon_{31}E_x + \varepsilon_{32}E_y + \varepsilon_{33}E_z\end{aligned}$$

- › If the coordinate system in a crystal structure is chosen to vanish off-diagonal elements, the axes in this coordinate system are defined as principal axes and a 3×3 electric permeability tensor can be expressed as

$$[\varepsilon] = \begin{bmatrix} \varepsilon_{11} & 0 & 0 \\ 0 & \varepsilon_{22} & 0 \\ 0 & 0 & \varepsilon_{33} \end{bmatrix}$$

Index Ellipsoid

- Recalling the electric energy density stored in a crystal

$$w_e = \frac{1}{2} \mathbf{E} \cdot \mathbf{D} \quad \text{and} \quad \mathbf{D} = \epsilon_0[\epsilon] \mathbf{E}$$

w_e takes a form of

$$w_e = \frac{1}{2} \left(\frac{D_x^2}{\epsilon_{11}} + \frac{D_y^2}{\epsilon_{22}} + \frac{D_z^2}{\epsilon_{33}} \right)$$

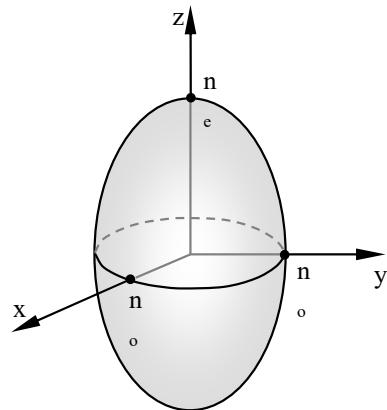
- Replacing $D_i/\sqrt{2\epsilon_0 w_e}$ where $i = x, y, z$ with $X, Y, \text{ and } Z$
we have the index ellipsoid described by

$$\frac{x^2}{n_x^2} + \frac{y^2}{n_y^2} + \frac{z^2}{n_z^2} = 1$$

where $n_x = \sqrt{\epsilon_{11}/\epsilon_0}$, $n_y = \sqrt{\epsilon_{22}/\epsilon_0}$, and $n_z = \sqrt{\epsilon_{33}/\epsilon_0}$
are principal refractive indices.

Index Ellipsoid of Uniaxial Crystal

- In the uniaxial crystal, it is noticed that $n_x = n_y = n_o$ and $n_z = n_e$ where n_o and n_e are called the ordinary and extraordinary indices, respectively and the z axis is called the optic axis



Electrooptic Tensor

- The presence of electric field applied in an arbitrary direction to a crystal leads to a linear change in the coefficient $1/n_i^2$ according to

$$\Delta\left(\frac{1}{n^2}\right)_i = \sum_j r_{ij}E_j \quad i = 1, \dots, 6, \quad j = 1, 2, 3$$

In a matrix form

$$\xrightarrow{\hspace{1cm}} \begin{vmatrix} \Delta(1/n^2)_1 \\ \Delta(1/n^2)_2 \\ \Delta(1/n^2)_3 \\ \Delta(1/n^2)_4 \\ \Delta(1/n^2)_5 \\ \Delta(1/n^2)_6 \end{vmatrix} = \begin{vmatrix} r_{11} & r_{12} & r_{13} \\ r_{21} & r_{22} & r_{23} \\ r_{31} & r_{32} & r_{33} \\ r_{41} & r_{42} & r_{43} \\ r_{51} & r_{52} & r_{53} \\ r_{61} & r_{62} & r_{63} \end{vmatrix} \begin{vmatrix} E_1 \\ E_2 \\ E_3 \end{vmatrix}$$

- The 6×3 electrooptic tensor composed of the electrooptic coefficient r_{ij} has a different form for noncentroelectric crystals.

The electrooptic tensor of LiNbO₃ - a uniaxial material of the 3m trigonal crystal class:

$$\begin{bmatrix} 0 & -r_{22} & r_{13} \\ 0 & r_{22} & r_{13} \\ 0 & 0 & r_{33} \\ 0 & r_{51} & 0 \\ r_{51} & 0 & 0 \\ -r_{22} & 0 & 0 \end{bmatrix}$$

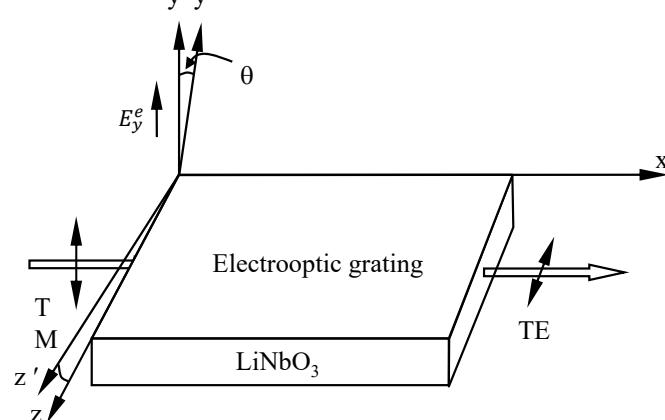
Axis transformation

- › The new index ellipsoid in the applied electric field is described by

$$\left(\frac{1}{n^2}\right)_1' x^2 + \left(\frac{1}{n^2}\right)_2' y^2 + \left(\frac{1}{n^2}\right)_3' z^2 + 2\left(\frac{1}{n^2}\right)_4' yz + 2\left(\frac{1}{n^2}\right)_5' xz + 2\left(\frac{1}{n^2}\right)_6' xy = 1$$

- › For various electric field directions in y-cut, x-propagating LiNbO₃, the electric field E_y^e applied uniformly along y axis is considered.

The index ellipsoid becomes $\left(\frac{1}{n_o^2} + r_{22}E_y^e\right)y^2 + \left(\frac{1}{n_e^2}\right)z^2 + 2r_{51}E_y^eyz = 1$



Axis transformation Continued...

- The existence of the mixed yz term implies the index ellipsoid is rotated about x axis and x , y , and z are no longer the principal axes. The perturbed index ellipsoid in new $x'y'$ plane is expressed by

$$\frac{y'^2}{n_{y'}^2} + \frac{z'^2}{n_{z'}^2} = 1$$

where

$$\begin{bmatrix} x \\ y' \\ z' \end{bmatrix} = [T] \begin{bmatrix} x \\ y \\ z \end{bmatrix}, \quad [T] = \begin{bmatrix} 1 & 0 & 0 \\ 0 & \cos \theta & -\sin \theta \\ 0 & \sin \theta & \cos \theta \end{bmatrix}$$

- Since practically $n_{x'} \simeq n_o$, $n_{y'} \simeq n_o$, and $n_{z'} \simeq n_e$ for LiNbO₃

$$[\varepsilon'] = \begin{bmatrix} n_{x'}^2 & 0 & 0 \\ 0 & n_{y'}^2 & 0 \\ 0 & 0 & n_{z'}^2 \end{bmatrix} \simeq \begin{bmatrix} n_o^2 & 0 & 0 \\ 0 & n_o^2 & 0 \\ 0 & 0 & n_e^2 \end{bmatrix} \quad [\varepsilon] = [T]^T [\varepsilon'] [T] \quad \xrightarrow{\hspace{1cm}} \quad [\varepsilon] = \begin{bmatrix} \varepsilon_{11} & 0 & 0 \\ 0 & \varepsilon_{22} & \delta\varepsilon_{23} \\ 0 & \delta\varepsilon_{23} & \varepsilon_{33} \end{bmatrix}$$

Axis transformation Continued...

- Considering the TM polarized optical wave propagates in a crystal and off-diagonal elements in the permeability tensor are induced by electric field E_y^e , the polarization $\delta\mathbf{P} = \epsilon_0([\epsilon'] - [\epsilon])\mathbf{E}$ is described by

$$\begin{bmatrix} \delta P_x \\ \delta P_y \\ \delta P_z \end{bmatrix} = \epsilon_0 \begin{bmatrix} 0 & 0 & 0 \\ 0 & 0 & -\delta\epsilon_{23} \\ 0 & -\delta\epsilon_{23} & 0 \end{bmatrix} \begin{bmatrix} 0 \\ E_y^\omega \\ 0 \end{bmatrix}$$

- Perturbation in the permeability tensor induced by electric field E_y^e gives rise to the perturbation in the optical wave E_y^ω written by .

$$\delta P_z = -\epsilon_0 \delta\epsilon_{23} E_y^\omega$$

TE↔TM Mode Converter

- › The TE↔TM mode conversion between two codirectional and orthogonal modes is described by the coupled mode equations

$$\begin{aligned}\frac{dA_m}{dx} &= -i\kappa B_m e^{-i\Delta\beta x} \\ \frac{dB_m}{dx} &= -i\kappa A_m e^{-i\Delta\beta x}\end{aligned}$$

where A_m and B_m are complex amplitudes of the two coupled optical waves

$$\Delta\beta \equiv \beta_{TM} - \beta_{TE}$$

$$\kappa = \frac{1}{2} (n_e n_o)^{3/2} k_0 r_{51} E_y^e$$

Solution of Coupled Mode Equations

- › Assuming the boundary conditions

$$\begin{aligned}A_m(x = 0) &= 0 \\B_m(x = 0) &= B_0\end{aligned}$$

the solutions are obtained as

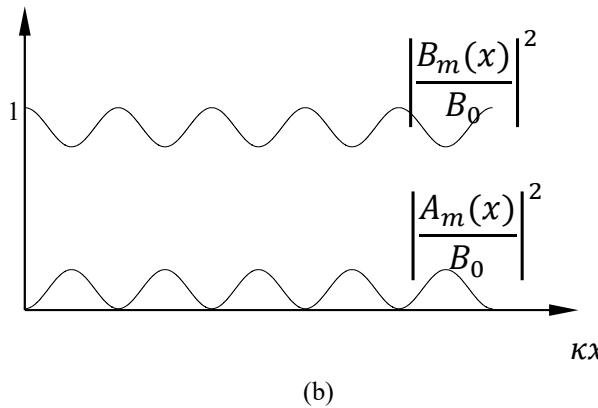
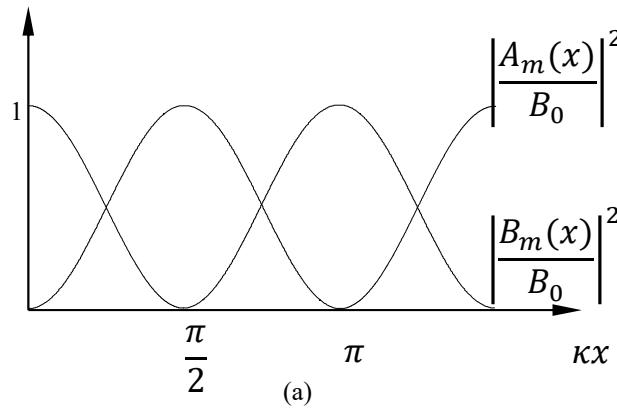
$$\begin{aligned}A_m(x) &= -B_0 e^{-\delta x} \frac{\kappa}{\sqrt{\kappa^2 + \delta^2}} \sin(\sqrt{\kappa^2 + \delta^2} x) \\B_m(x) &= B_0 e^{-\delta x} \left[\cos(\sqrt{\kappa^2 + \delta^2} x) - \frac{i\delta}{\sqrt{\kappa^2 + \delta^2}} \sin(\sqrt{\kappa^2 + \delta^2} x) \right] \\ \text{where } \delta &\equiv \frac{1}{2}(\beta_{TM} - \beta_{TE})\end{aligned}$$

- › When the two modes are phase matched, we have the simpler solution

$$\begin{aligned}A_m &= -B_0 \sin(\kappa x) \\B_m &= B_0 \cos(\kappa x)\end{aligned}$$

Power conversion over coupling length

- The plot of the normalized powers $|A_m(x)/B_0|^2$ and $|B_m(x)/B_0|^2$

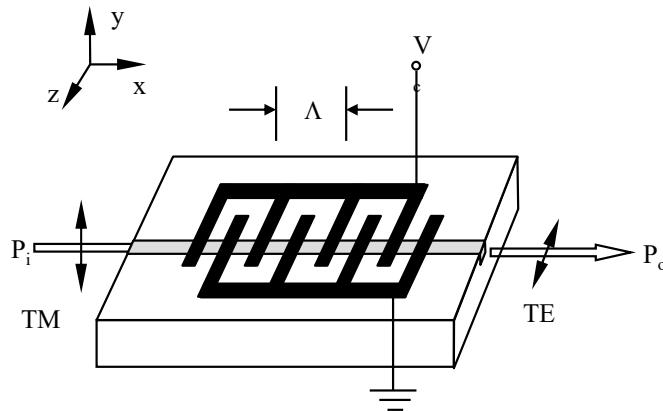


- The shortest coupling length L for full power transfer is denoted by

$$L = \frac{\pi}{2\kappa}$$

Power conversion over coupling length Continued...

- Full power transfer requires phase-matching condition that $\beta_{TM} = \beta_{TE}$ in the uniform waveguide structure and $\beta_{TM} - \beta_{TE} = 2\pi/\Lambda$ in the periodic structure



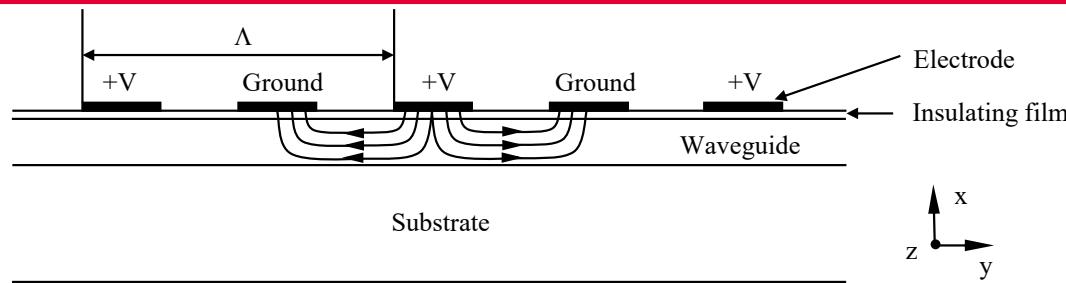
- The periodicity of the structure compensates the difference between two propagation constants
- Assuming the phase-matching condition at a certain wavelength, the polarization converter behaves as a wavelength filter and the optical bandwidth of $TE \leftrightarrow TM$ conversion becomes

$$\Delta\lambda_{FWHM} \approx 0.8 \left(\frac{\Lambda}{L} \right) \lambda$$

III. Design of Electrooptic Matched Filter

A. The Principal Characteristics of EMF

- › The x component of electric field provides $\text{TE} \leftrightarrow \text{TM}$ mode conversion induced by $\delta\epsilon_{23}$ perturbation in the permeability tensor via the electrooptic coefficient r_{51}



- › The mode conversion is a wavelength selective process. The most efficient wavelength λ_0 is found by the phase-matching condition as

$$\lambda_0 = \Lambda |n_{TM} - n_{TE}|$$

Λ : the period of interdigital electrodes

n_{TM} , n_{TE} : the effective refractive indices of the TM and TE modes

Principal Characteristics of EMF Continued...

- Wavelength selection is achieved if the first order phase-matching condition $\Delta = 0$ is satisfied, where the phase mismatch constant Δ is

$$\Delta = \frac{2\pi v(n_{TM} - n_{TE})}{c} \pm \frac{2\pi}{\Lambda}$$

- Hence, the tuning mechanism can be described by applying the voltage to the electrodes to nullify Δ at any desired frequency
- The sidelobe levels are suppressed to below -10 dB by applying a raised cosine apodizing function

$$\kappa(y) = \kappa_0 + 0.5\kappa_0 \cos \left[2\pi \left(\frac{y}{L} - 0.5 \right) \right]$$

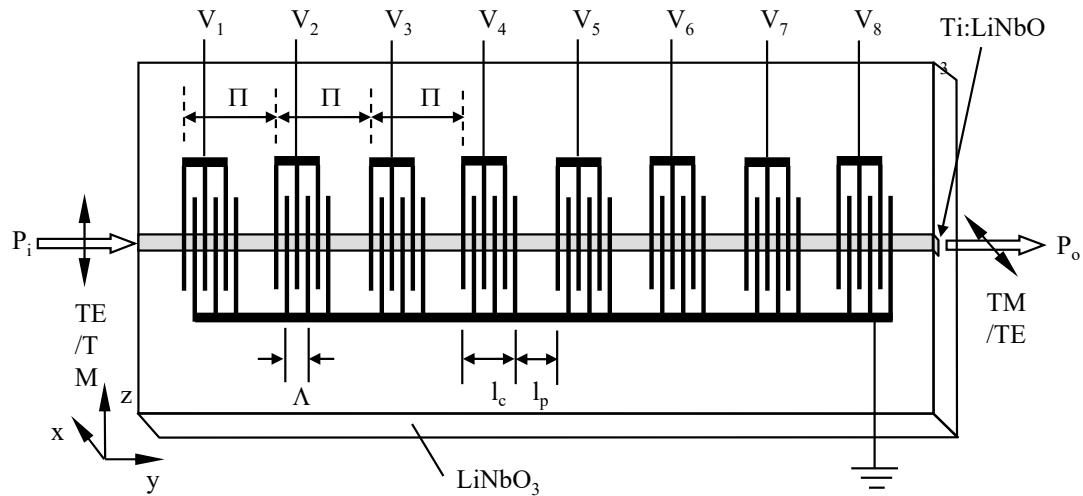
III. Design of Electrooptic Matched Filter

B. The EMF Structure for Two Sidebands

- › The array of electrode sets is formed on the waveguide which is fabricated on an x-cut y-propagating LiNbO₃ substrate by Ti diffusion

- › The EMF is composed of 8 sets of interdigital electrodes to tune 5 wavelength channels according to the relation $N = P/2 + 1$ where N : the number of selectable channels,
 P : the number of electrode sets

EMF Structure for Two Sidebands Continued...



$\Lambda = 21 \mu\text{m}$: spatial period of interdigital electrodes

$\Pi = 200 \cdot \Lambda$: period of electrode sets

$l_c = (179 + 3/4) \cdot \Lambda$: length of single mode conversion region

Coupling Strength Distribution

- › The ideal coupling strength distribution along the length of the electrode sets in the structure for two sidebands is

$$\kappa_j(y) = S(y) \cos(\Delta_j y), \quad j = 1, 2, 3, \dots, N$$

$S(y)$: the apodization function

$$\Delta_j = \frac{2\pi |n_{1g} - n_{3g}| (\nu_j - \nu_0)}{c}$$

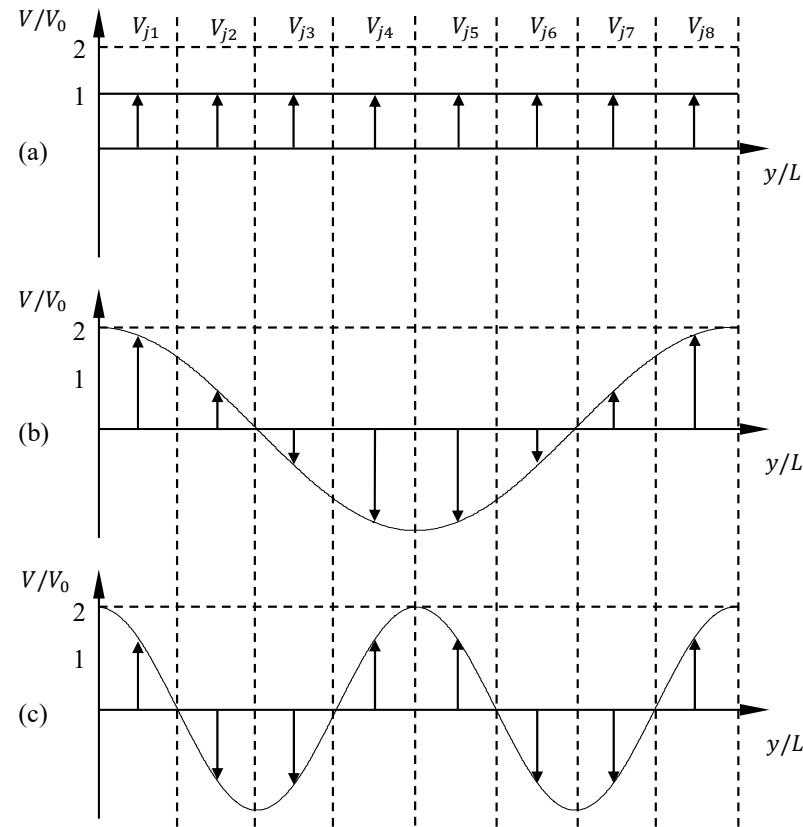
- › The integral of coupling coefficient over the interaction length L is given by

$$\int_0^L \kappa dy = \frac{\pi}{2}$$

for a complete TE \leftrightarrow TM power conversion

Applied Voltages to Eight Sets of Electrodes

- In this research, V_0 is obtained experimentally to optimize the polarization conversion



The Ratio of V_{jp} to V_0 – Two Sidebands

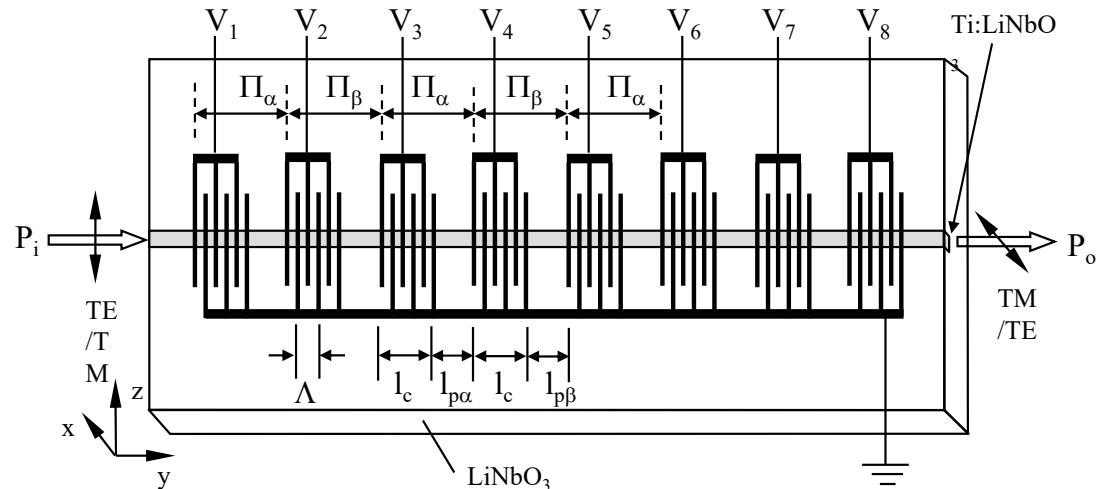
- The voltages for the raised cosine apodization are obtained by using equation

$$\kappa_j(y) = S(y) \cos(\Delta_j y)(1 + 0.5 \cos\left[2\pi\left(\frac{y}{L} - 0.5\right)\right])$$

j, channel		p, the number of electrode set							
		1	2	3	4	5	6	7	8
Without apodization	0	1	1	1	1	1	1	1	1
	± 1	1.848	0.765	-0.765	-1.848	-1.848	-0.765	0.765	1.848
	± 2	1.414	-1.414	-1.414	1.414	1.414	-1.414	-1.414	1.414
With raised cosine apodization	0	0.538	0.809	1.191	1.462	1.462	1.191	0.809	0.538
	± 1	0.994	0.619	-0.912	-2.701	-2.701	-0.912	0.619	0.994
	± 2	0.761	-1.144	-1.685	2.067	2.067	-1.685	-1.144	0.761

III. Design of Electrooptic Matched Filter

C. The EMF Structure for Single Sideband



$\Lambda = 21 \mu m$: spatial period of interdigital electrodes

$$\Pi_\alpha = (200 - 1/4)\Lambda , \quad \Pi_\beta = (200 + 1/4)\Lambda$$

$l_c = (179 + 3/4) \cdot \Lambda$: length of single mode conversion region

Coupling Strength Distribution

- › The regions of Π_α and Π_β cause in-phase and quadrature coupling, respectively. The coupling coefficient is complex and is written by

$$\kappa_j(y) = S(y)e^{i\Delta_j y}$$

- › For the in-phase and quadrature coupling, the coupling coefficient κ_j is written by

$$\kappa_j(y) = S(y) \cos(\Delta_j y), \quad j = \pm(2n - 1)$$

$$\kappa_j(y) = iS(y) \sin(\Delta_j y), \quad j = \pm 2n$$

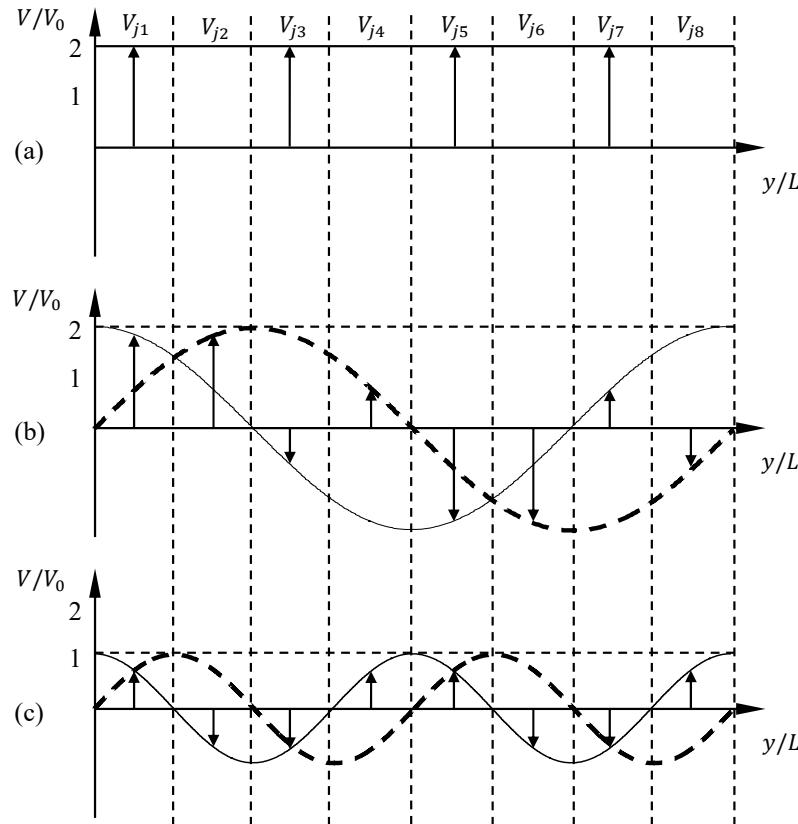
- › The selected voltages for j 'th frequency channel satisfy the relation

$$\int_0^L \kappa_j(y) e^{-i\Delta_k y} dy = \frac{\pi}{2} \delta_{jk}$$

with $\delta_{jk} = 1$ if $j = k$ and $\delta_{jk} = 0$ otherwise

Applied Voltages to Eight Sets of Electrodes

- Selection of voltages in the structure of a single sideband: (a) for $j = 0$ sideband, (b) for $j = 1$ sideband, (c) for $j = 2$ sideband.



The ratio of V_{jp} to V_0 – Single Sideband

j, channel		p, the number of electrode set							
		1	2	3	4	5	6	7	8
Without apodization	-2	0.707	-0.707	-0.707	0.707	0.707	-0.707	-0.707	0.707
	-1	1.848	-1.848	-0.765	-0.765	-1.848	1.848	0.765	0.765
	0	2	0	2	0	2	0	2	0
	1	1.848	1.848	-0.765	0.765	-1.848	-1.848	0.765	-0.765
	2	0.707	0.707	-0.707	-0.707	0.707	0.707	-0.707	-0.707
With raised cosine apodization	-2	0.380	-0.572	-0.842	1.034	1.034	-0.842	-0.572	0.380
	-1	0.994	-1.494	-0.912	-1.119	-2.701	2.201	0.619	0.412
	0	1.076	0	2.383	0	2.924	0	1.617	0
	1	0.994	1.494	-0.912	1.119	-2.701	-2.201	0.619	-0.412
	2	0.380	0.572	-0.842	-1.034	1.034	0.842	-0.572	-0.380

III. Design of Electrooptic Matched Filter

D. Matrix Formulation and Simulation Results

- › The effect of polarization conversion in the j'th coupling region and of phase shift in the spacing between electrodes is written by

$$\mathbf{E}_{j+1} = \mathbf{M}_j \mathbf{E}_j$$

where $\mathbf{E}_j = \begin{pmatrix} E_j^{TE} \\ E_j^{TM} \end{pmatrix}, \quad j = 1, 2, 3, \dots, P$

E_j^{TM} , E_j^{TE} : electric field amplitudes of two polarization modes just prior to the j'th coupling region

Matrix Formulation Continued...

- › The 2×2 transfer matrix \mathbf{M}_j is given by $\mathbf{M}_j^C \mathbf{M}^\Phi$
- › Here, the matrix \mathbf{M}^Φ describes the phase shift occurring at the propagation region between adjacent coupling regions, which is given by

$$\mathbf{M}^\Phi = \begin{bmatrix} e^{-i\frac{\varphi}{2}} & 0 \\ 0 & e^{i\frac{\varphi}{2}} \end{bmatrix}$$

where $\varphi = (\beta_1 - \beta_2)l_p$ $\beta_1 = 2\pi v n_{TE}/c$ $\beta_2 = 2\pi v n_{TM}/c$ $l_p = \Pi - l_c$

- › The matrix \mathbf{M}_j^C representing the effect of polarization conversion at the j 'th coupling region is in general written by adapting the well known solution of the coupled mode equations

$$\mathbf{M}_j^C = \begin{bmatrix} a_c e^{-i(\beta_1 + \frac{\Delta}{2})l_c} & b_c e^{-i(\beta_1 + \frac{\Delta}{2})l_c} \\ -b_c^* e^{-i(\beta_2 - \frac{\Delta}{2})l_c} & a_c e^{-i(\beta_2 - \frac{\Delta}{2})l_c} \end{bmatrix} \text{ where } \begin{aligned} a_c &= \cos(\sqrt{\kappa^2 + \delta^2}l_c) + i \frac{\delta}{\sqrt{\kappa^2 + \delta^2}} \\ b_c &= -i \frac{\delta}{\sqrt{\kappa^2 + \delta^2}} \sin(\sqrt{\kappa^2 + \delta^2}l_c) \end{aligned}$$

Conversion Matrix

- › The EMF consists of the first coupling region and the $P - 1$ pairs of alternating polarization conversion region and the spacing between them, so that the conversion matrix is given by

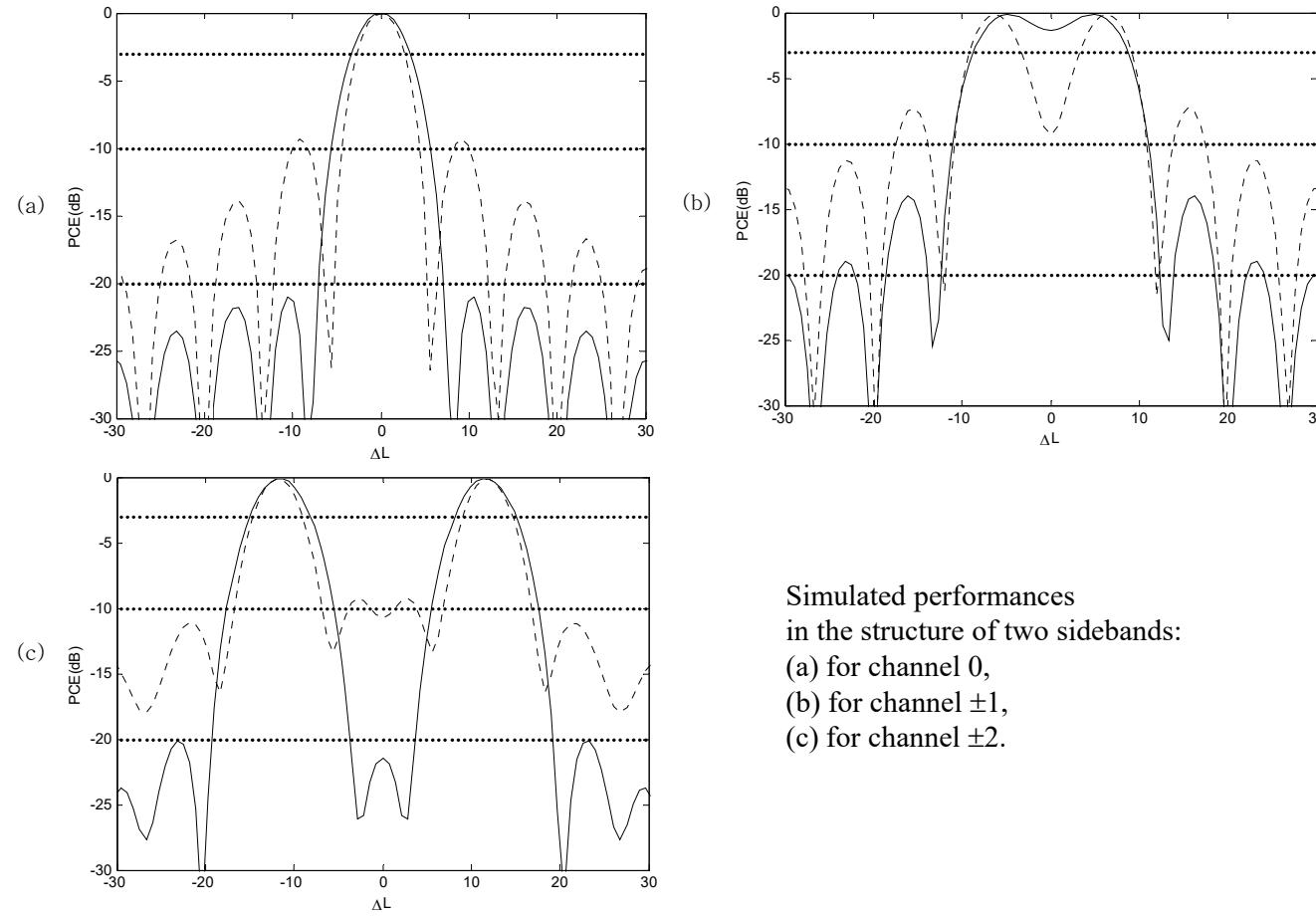
$$C = \left(\prod_{j=2}^P \mathbf{M}_j^C \mathbf{M}^\Phi \right) \mathbf{M}_1^C$$

- › Assuming that the TE polarization mode is excited at the input of EMF and its amplitude is normalized to 1, the power coupling efficiency is written by

$$PCE = |C_{12}|^2$$

where C_{12} is the off-diagonal element of the matrix C

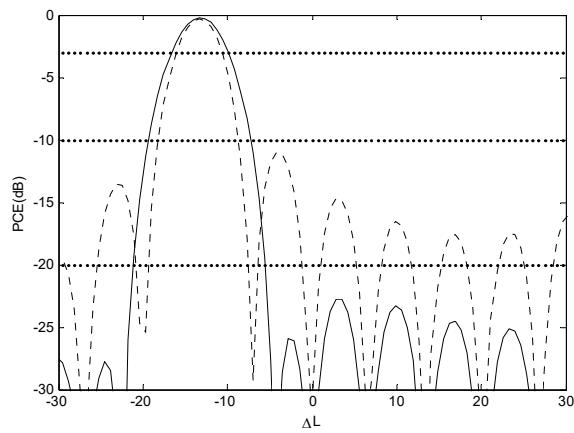
Simulation Result – Two Sidebands



Simulated performances
in the structure of two sidebands:
(a) for channel 0,
(b) for channel ± 1 ,
(c) for channel ± 2 .

Matrix Formulation for Single Sideband

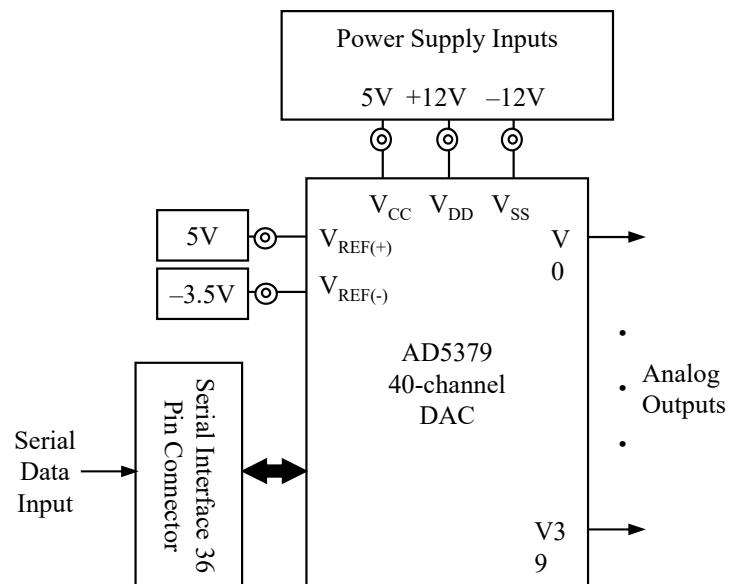
- › The transfer matrix for single sideband configuration can be described except that the matrix $\mathbf{M}^{\Phi\beta}$ is replaced with \mathbf{M}^Φ if j is the even number and $\mathbf{M}^{\Phi\alpha}$ otherwise.
- › φ_α and φ_β are used instead of φ , respectively where
$$\varphi_\alpha = (\beta_1 - \beta_2)l_{p\alpha}$$
$$\varphi_\beta = (\beta_1 - \beta_2)l_{p\beta}$$
- › Simulated performance in the single sideband configuration for channel –2



IV. Electronic Driving Circuit for EMF

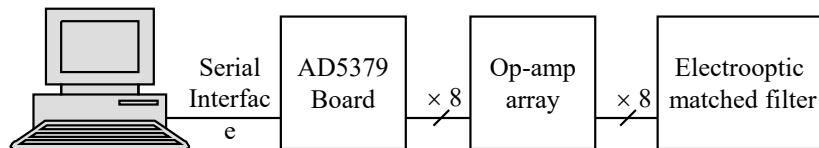
A. Digital-to-Analog Converter Driving Circuit

- › The EMF is controlled by applying different voltages to each electrode set independently
- › The AD5379 contains 40 DACs in one package and provides the maximum output voltage span of 17.5 V



Electronic Driving Circuit Configuration

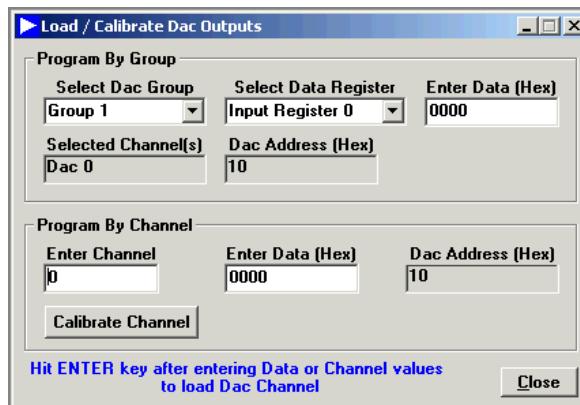
- › In this research, programmable data inputs are loaded from a personal computer memory into the AD5379 input registers by serial interface
- › The DAC output voltages are insufficient to directly drive the EMF, so an external op-amp array is utilized to obtain higher voltages



IV. Electronic Driving Circuit for EMF

B. Loading DAC Channels

- › All channels or each channel can be loaded manually with the entered DAC code
- › The AD5379 accepts 14-bit data word format for the serial interface



14-bit data word	Hexidecimal	Offset
11 1111 1111 1111	3FFF	+8191
11 1111 1111 1110	3FFE	+8190
10 0000 0000 0001	2001	+1
10 0000 0000 0000	2000	0
01 1111 1111 1111	1FFF	-1
00 0000 0000 0001	0001	-8191
00 0000 0000 0000	0000	-8192

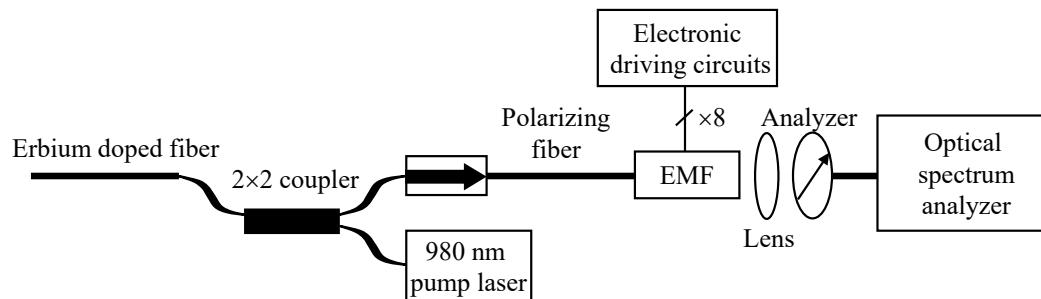
- › The hexadecimal code can be decoded as follows:

$$V = \left(V_{OUT_{max}} \times \frac{HEX2DEC(Hex) - 8192}{8192} \right) \times G$$

V. Experimental Results

A. Experimental Configuration

- Optical testing was carried out using the amplified spontaneous emission (ASE) from a broadband light source of an erbium-doped fiber pumped by a 980 nm laser diode

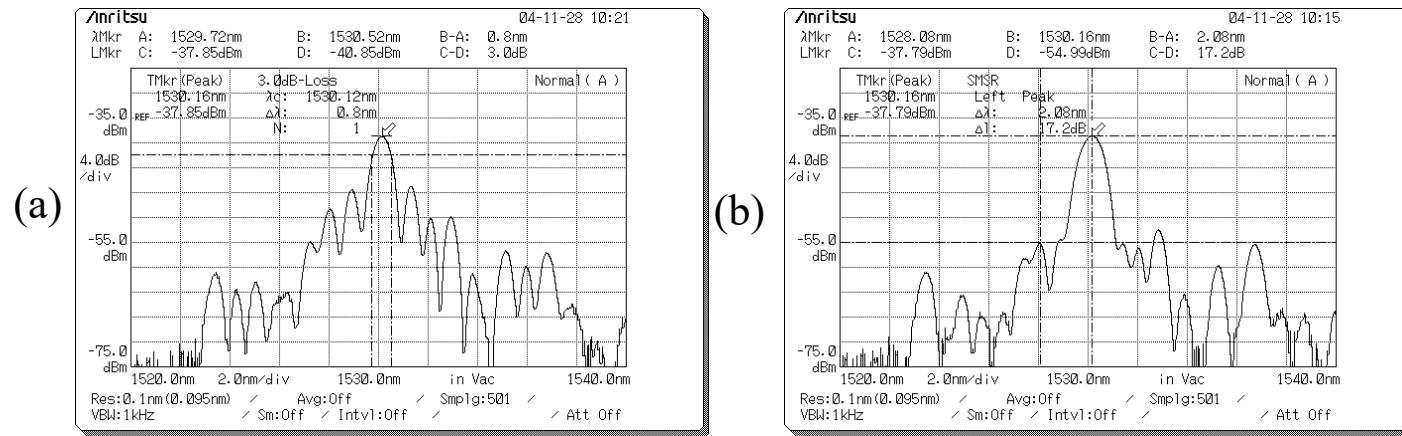


- External electronic circuits drive 8 independent sets of electrodes by using a DAC array
- The transmitted beam, after it passes through the EMF and the optical polarizer, is monitored with an optical spectrum analyzer

V. Experimental Results

B. Test Results

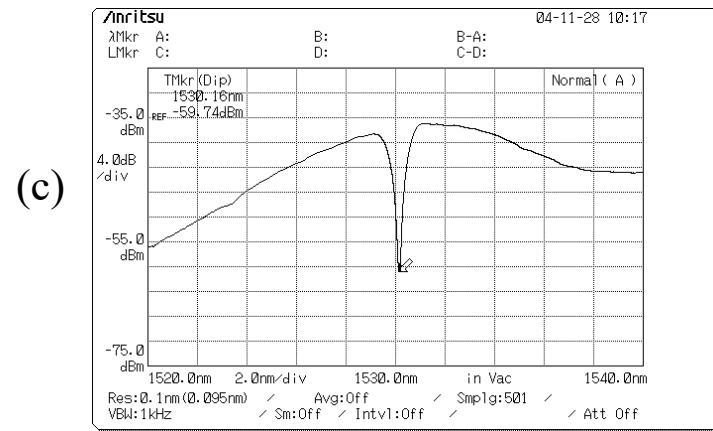
- › The optical output power spectra of EMF for TE→TM polarization conversion in the structure for two sidebands: (a) unapodized and (b) apodized filter responses of TM mode at channel 0



- › A uniform coupling voltage $V_0 = 13$ V
- › The optical bandwidth (FWHM) of 0.8 nm is in close agreement with the calculated value
- › A sidelobe suppression level better than –17 dB is achieved

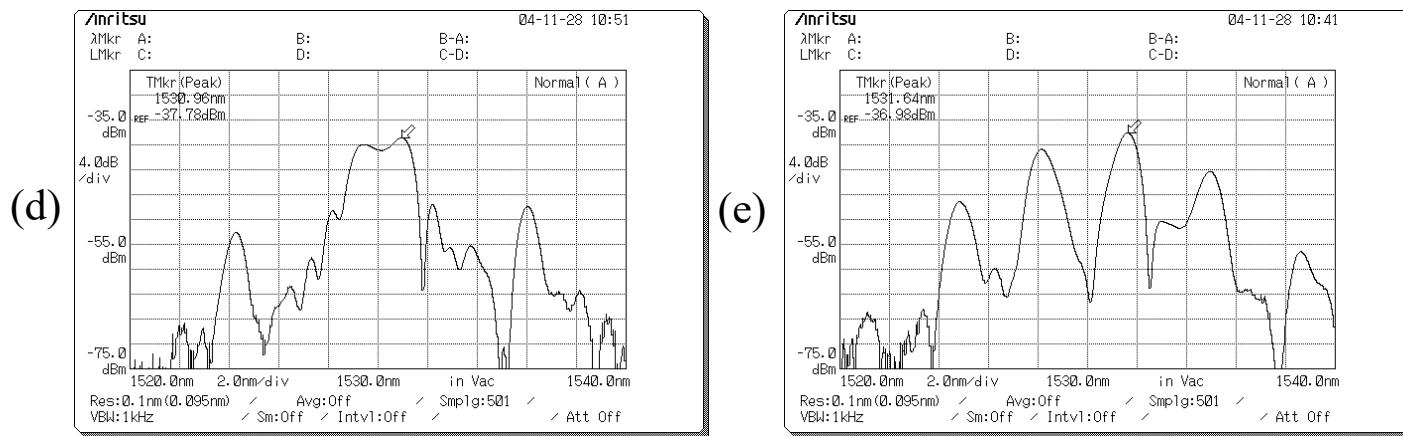
Test Result at Channel 0 Continued...

- › The optical output power spectra of EMF for TE→TM polarization conversion in the structure for two sidebands: (c) apodized filter response of TE mode at channel 0



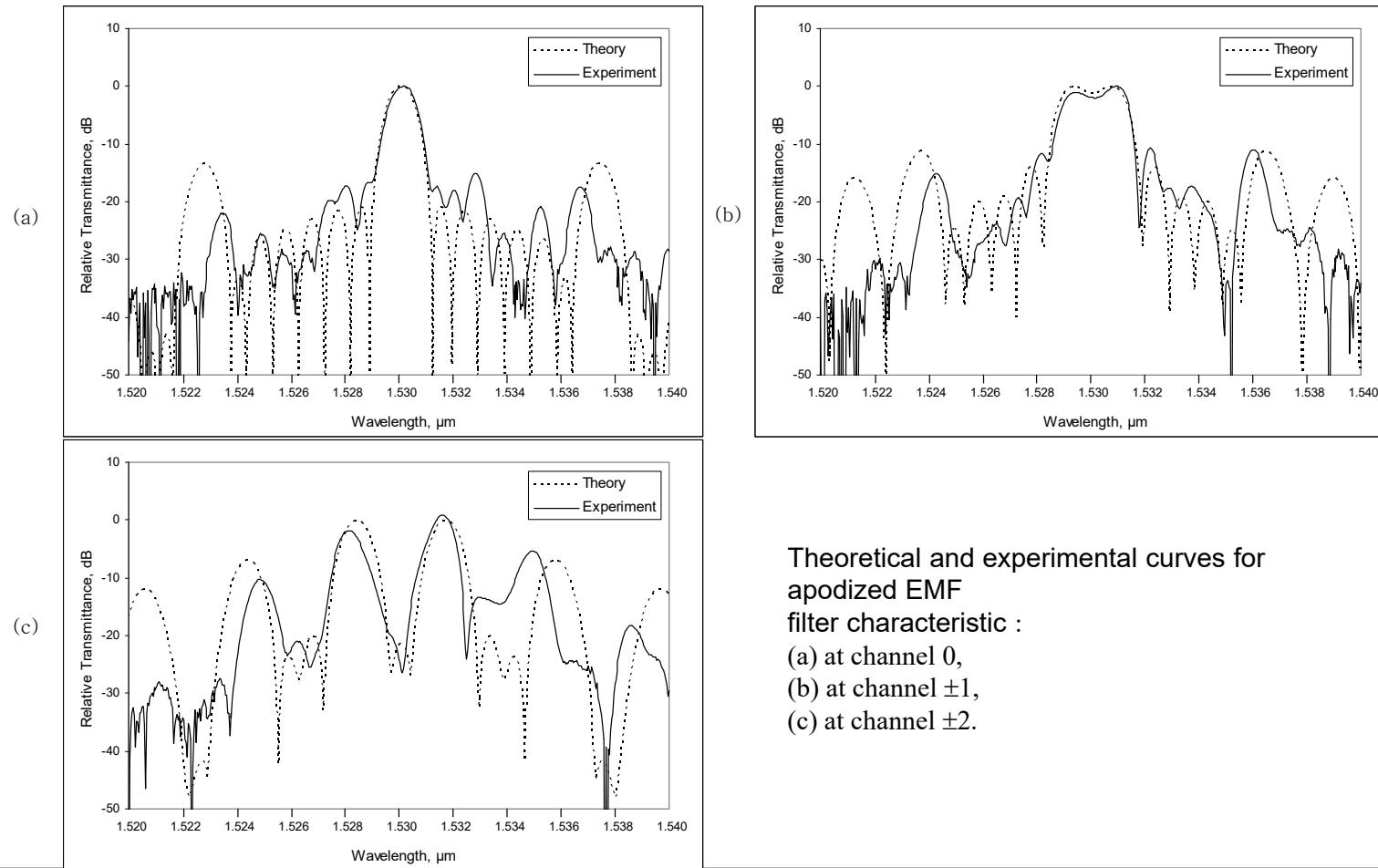
Test Results at Channel ± 1 and ± 2

- › The optical output power spectra of EMF for TE \rightarrow TM polarization conversion in the structure for two sidebands:
(d) apodized output power responses of TM mode at channel ± 1 and (e) channel ± 2



- › The filter performance of TM \rightarrow TE polarization conversion is similar to that of TE \rightarrow TM conversion

Theoretical and Experimental Curves



Theoretical and experimental curves for
filter characteristic :
(a) at channel 0,
(b) at channel ± 1 ,
(c) at channel ± 2 .

VI. Conclusions

- › The EMF is designed for operation in the 1530 nm spectral regime
- › The device utilizes TE↔TM polarization conversion in a single mode waveguide fabricated in LiNbO₃ by Ti diffusion
- › The performance of EMF - inherently independent of the input polarization because of the reciprocal characteristic between TE and TM mode polarization conversion
- › The spectral tuning range of 3.2 nm for 5 channels is demonstrated. More channels can be accommodated by increasing the number of electrode sets (e.g., if $P = 198$, then $N = 100$) with the length of the device unchanged
- › A tuning speed of less than 50 ns was achieved previously in a LiNbO₃ tunable filter, and similar fast tuning is expected in the EMF
- › Apodization improves the sidelobe suppression from –8.6 dB to –17.2 dB

VII. Recommendations

- › The structure for single sideband with more than 8 electrode sets can realize good filter characteristics showing close agreement with prediction
- › New electronic components to provide higher voltage supply can facilitate the experiments
- › The EMF can be configured for a 4 port add-drop multiplexer and a two port bandpass filter of a Mach-Zehnder interferometer structure
- › The spectral tuning range of the EMF for coarse WDM application can be improved by using a LiTaO₃ substrate because the birefringence of LiTaO₃ is much less than that of LiNbO₃